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(71) Applicant: TESSERA, DNC. [US/US]; 3099 Orchard Drive, San Jose, CA 95134 (US).

(73) Inventors: NOUYEN, Tare 1769 Laine Avenue, Santa Clara, CA 95051 (US). MITCHELL, Crafg. 8; 1343 Geneva Drive, Santa Clara, CA 95051 (US). DISTEFANO, Thomas, CA 95051 (US). DISTEFANO, Thomas, CA 95051 (US). H.; 16129 Orsenwood Lane, Monte Sereno, CA 95030 (US).

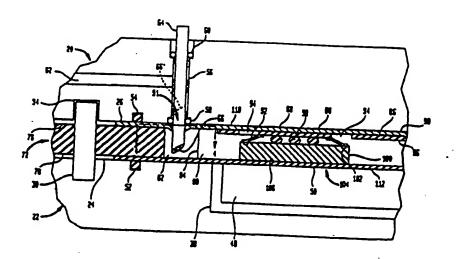
(74) Agents MILLET, Marcus, J. et al.; Lorner, David, Littenberg. Krumholz & Mentik, LLP, 600 South Avenue West, Westfield, NJ 07090 (US).

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(54) Tule: Encapsulation of Microelectronic assemblies



(57) Abstract

Microelectronic assemblies are encapsulated using disposable frames (72). The microelectronic assemblies (104) are disposed within an aperture (80) defined by a frame. The aperture is covered by top and bottom scaling layers (110, 112) so that the frame and scaling layers define an enclosed space encompassing the assemblies. The encapsulant is injected into this closed space. The frame is then separated from the encapsulation fixture and held in a curing oven. After cure, the frame is cut apart and the individual assemblies are severed from another. Secause the frame need not be held in the accomplished fixture during curing the covered achieves a high theory should another. Because the frame need not be held in the encapsulation fixture during curing, the process achieves a high throughput.